UTILITY PATENT APPLICATION TRANSMITTAL (Only for new nonprovisional applications under 37 CFR 1.53(b))

jc860 U.S. PTO 04/25/01

Attorney Docket No.	206584U	<u>52</u>
First Inventor or Applic	ation Identifier	T

Tsuneyuki 📙

ARA, et al.

AERIAL IMAGE MEASUREMEN ZATE THOD AND UNIT, OPTICAL PROPERTIES MEASUREMENT METHOD AND UNIT, ADJUSTING METHOD OF PROJECTION OPTICAL SYSTEM, EXPOSURE METHOD AND APPARATUS, MAKING METHOD OF EXPOSURE APPARATOR AND DEVICE MANUFACTURING METHOD

Assignee Name: Nikon Corporation

Assignee Address:

2-3, Marunouchi 3-chome, Chiyoda-ku, Tokyo, 100-8331 Japan

APPLICATION ELEMENTS See MPEP chapter 600 concerning utility patent application contents	Assistant Commissioner for Patents ADDRESS TO: Box Patent Application Washington, DC 20231				
Fee Transmittal Form (e.g. PTO/SB/17) (Submit an original and a duplicate for fee processing)	ACCOMPANYING APPLICATION PARTS				
	7. Assignment Papers (cover sheet & document(s))				
2. ■ Specification Total Sheets 101	8. □ Application Data Sheet. See 37 CFR 1.76				
	9. 37 C.F.R. §3.73(b) Statement Power of Attorney (when there is an assignee)				
3. ■ Drawing(s) (35 U.S.C. 113) Total Sheets	10. □ English Translation Document (if applicable)				
	11. Information Disclosure Statement (IDS)/PTO-1449 Copies of IDS Citations				
4. □ Oath or Declaration Total Pages	12. □ Preliminary Amendment				
a. Newly executed (original or copy)	13. ■ White Advance Serial No. Postcard				
b. Copy from a prior application (37 C.F.R, §1.63(d)) (for continuation / divisional w/ box 17 completed)	14. □ Certified Copy of Priority Document(s) (if foreign priority is claimed)				
 DELETION OF INVENTOR(S) Signed statement attached deleting inventor(s) named in the prior application, see 37 C.F.R. §1.63(d)(2) and 1.33(b). 	15. □ Applicant claims small entity status.				
5. ☐ CD-ROM or CD-R in duplicate, large table or Computer Program (<i>Appendix</i>)	16. ■ Other: Notice of Priority, List of Inventors' Names and Addresses, Statement Re Filing in				
6. ☐ Nucleotide and/or Amino Acid Sequence Submission (if applicable, all necessary)	Foreign Language				
a. Computer Readable Form (CRF)					
b. Specification or Sequence Listing on:					
i. □ CD-ROM or CD-R (2 copies); or					
ii. paper	· ·				
c. Statements verifying identity of above copies					
17. If a CONTINUING APPLICATION, check appropriate box, and sup-	ply the requisite information below:				
□ Continuation □ Divisional □ Continuation					
Prior application information: Examiner:	Group Art Unit:				
• •	or application, from which an oath or declaration is supplied under Box 4b, is				
For CONTINUATION OR DIVISIONAL APPS only: The entire disclosure of the prior application, from which an oath or declaration is supplied under Box 4b, is considered a part of the accompanying continuation or divisional application and is hereby incorporated by reference. The incorporation can only be relied upon when a portion has been inadvertently omitted from the submitted application parts.					
18. Amend the specification by inserting before the first line the se	entence:				
☐ This application is a ☐ Continuation ☐ Division ☐ Continuation-in-part (CIP)					
of application Serial No. Filed on					
☐ Which was published in English					
□ Which was not published in English	al No. Filed				
☐ This application claims priority of provisional application Seria	ii INO. Filed				
19. CORRESPONDENCE ADDRESS					
. 22850 (703) 413-3000					
(703) 41 FACSIMILE: (7					

Name:	Marvin J. Spivak	Registration No.:	24,913
Signature:	Chm Mchan	Date:	4/25/01
Name:	C. Irvin Wederland Bogistration Number 21,124	Registration No.:	

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) Tsuneyuki HAGIWARA, et al.

SERIAL NO:

New Application

FILING DATE: Herewith

FOR:

AERIAL IMAGE MEASUREMENT METHOD AND UNIT, OPTICAL PROPERTIES MEASUREMENT METHOD AND UNIT, ADJUSTMENT METHOD OF PROJECTION OPTICAL SYSTEM, EXPOSURE METHOD AND APPARATUS, MAKING METHOD OF EXPOSURE APPARATUS, AND DEVICE

MANUFACTURING METHOD

FEE TRANSMITTAL

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

FOR	NUMBER FILED	NUMBER EXTRA	RATE	CALCULATIONS
TOTAL CLAIMS	44 - 20 =	24	× \$18 =	\$432.00
INDEPENDENT CLAIMS	5 - 3 =	2	× \$80 =	\$160.00
□ MULTIPLE DEPENDENT CLAIMS (If applicable) + \$270 =			\$0.00	
■ LATE FILING OF DECLARATION + \$130 =			\$130.00	
	\$710.00			
TOTAL OF ABOVE CALCULATIONS				\$1,432.00
□ REDUCTION BY 50% FOR FILING BY SMALL ENTITY				\$0.00
■ FILING IN NON-ENGLISH LANGUAGE		+ \$130 =	\$130.00	
□ RECORDATION OF ASSIGNMENT		+ \$40 =	\$0.00	
			TOTAL	\$1,562.00

Please charge Deposit Account No. 15-0030 in the amount of

A duplicate copy of this sheet is enclosed.

A check in the amount of

\$1,562.00

to cover the filing fee is enclosed.

The Commissioner is hereby authorized to charge any additional fees which may be required for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Marvin J. Spivak

Registration No. 24,913 C. Irvin McClelland

Registration Number 21,124

22850Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 10/00)

4/25/01

Docket No.

206584US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Tsuneyuki HAGIWARA, et al.

FILING DATE: Herewith

FOR:

AERIAL IMAGE MEASUREMENT METHOD AND UNIT, OPTICAL PROPERTIES MEASUREME. . . METHOD AND UNIT, ADJUSTMENT METHOD OF PROJECTION OPTICAL SYSTEM, EXPOSURE METHOD AND APPARATUS, MAKING METHOD OF EXPOSURE APPARATUS, AND DEVICE

MANUFACTURING METHOD

LIST OF INVENTORS' NAMES AND ADDRESSES

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

Listed below are the names and addresses of the inventors for the above-identified patent application.

Tsuneyuki HAGIWARA

Tokyo, Japan

Naoto KONDO

Tokyo, Japan

Eiji TAKANE

Tokyo, Japan

Hiromi KUWATA

Tokyo, Japan

Kousuke SUZUKI

Tokyo, Japan

A declaration containing all the necessary information will be submitted at a later date.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,

MAIER & NEUSTADT, P.C.

22850

Tel. (703) 413-3000

Fax. (703) 413-2220 (OSMMN 11/98)

Marvin J. Spivak

Registration No.

24,913

C. Irvin McClelland Registration Number 21,124 Docket No.

206584US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Tsuneyuki HAGIWARA, et al.

SERIAL NO.

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AERIAL IMAGE MEASUREMENT METHOD AND UNIT, OPTICAL PROPERTIES MEASUREMENT METHOD AND UNIT, ADJUSTMENT METHOD OF PROJECTION OPTICAL SYSTEM, EXPOSURE METHOD AND APPARATUS, MAKING METHOD OF EXPOSURE APPARATUS, AND DEVICE

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STATEMENT RE FILING IN FOREIGN LANGUAGE

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

It is hereby stated that the subject application is being filed in a foreign language, in accordance with the provisions Ō #of 37 CFR 1.52(d).

An accurate English translation, and a suitable amendment placing the application and claims thereof into proper U.S. format if needed, will be filed in due course. Ţ

Fax. (703) 413-2220 (OSMMN 10/98)

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Marvin J. Spivak

Registration No. 24,913

C. Irvin McClelland Registration Number 21,124